## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#1/2/AA 18eb 12-19-02

IN RE THE APPLICATION OF	)
Andreas Wittmann et al.	) Examiner:
	) Group Art Unit No.
SERIAL NO.: To Be Assigned	)
FILED: Herewith	)
FOR: Anti-Reflection Coatings for Semiconductor	)
Lasers	)
	Thereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to "Director of Patents and Trademarks, Washington, D.C. 20231, Box: Application" on November 6, 2001.
	Name of person signing Deborah E. Dudek Signature Deborah E. Dudek

## **AMENDMENT ACCOMPANYING APPLICATION**

Honorable Director of Patents and Trademarks Washington, D.C. 20231

Dear Sir:

It is requested that this application be amended as follows:

## In the Specification

Page 1, after the title, add the following section:

-- RELATED APPLICATION

This application is the non-provisional filing of Provisional Application No. 60/293,738,

filed May 25, 2001, the priority of which is claimed.--

November 6, 2001

Respectfully submitted

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